

Security Information

6 July 1953

MEMORANDUM TO: Director of Training

VIA:

Personnel Director
Director of Security

FROM:

Chief, Personnel Procurement

SUBJECT:

Request for Permission to Attend Conference
on USSR at SAIS

1. In accordance with the provisions of the memorandum dated 19 June, 1953, from the Director of Training concerning the method for requesting permission to attend the one week conference on the USSR at the Sheraton-Park Hotel, sponsored by SAIS, Johns Hopkins University, I should like to ask for permission to personally attend the meetings myself, in whole or in part, for the dual purpose of spotting qualified individuals for Agency employment in USSR areas, and also to increase my own awareness of the problems this country faces vis-a-vis the Soviet Union. Since a large part of our recruitment effort is directed toward convincing qualified people to work for us on the Soviet problem, I would like to see if this conference would give recruitment any new arguments to use in the field.

2. The following information, requested in the subject memorandum, is herewith supplied:

(a) Mr. [REDACTED]

GS-15

(b) Personnel Procurement Division, Personnel Office

(c) Chief, Personnel Procurement

(d) I should like to attend as much of the conference as I am able, based upon the then-existing work load in this division.

[REDACTED]

NO SECURITY OBJECTIONS

Employee will make no reference to, or discuss his CIA activities while participating in

[REDACTED]

Chief, Personnel Procurement

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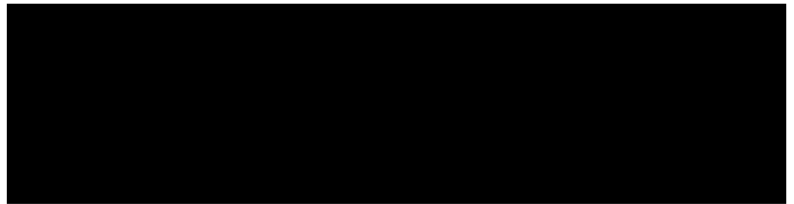
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School, Brown University, two semesters post war; received one-half necessary credits toward A.M. degree.

(f) I would like to attend the banquet, but cannot say at this time that I will be able to do so.

3. Your approval of the above is earnestly requested.

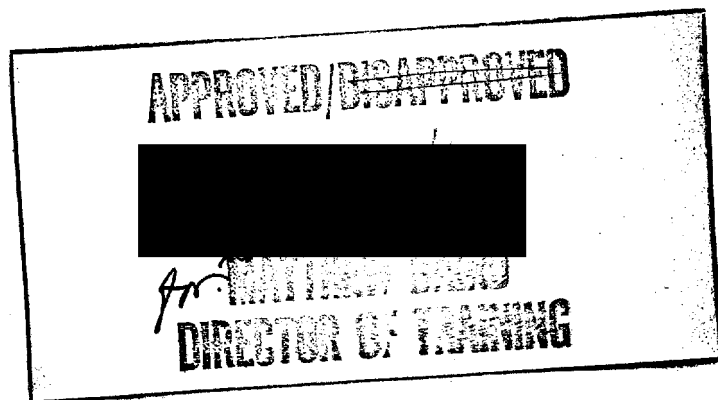
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PPD/JAC, JR:vp (6 July 1953)

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